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**PATENT** 

Docket No.: JCLA12331

Date: 10-8-200

03917 US PTO 10/682370

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

ATTENTION: APPLICATION BRANCH

Sir:

Transmitted herewith for filing under 37 C.F.R. 1.53(b) is the patent application of

Inventor(s): AKIRA ISHII;

JUN MITSUDO;

For: METHOD FOR MEASURING HEIGHT OF SHPERE OF HEMISPHERE

(X) This application claims the priority benefit of Japan application No. 2002-297709 filed on October 10, 2002.

Enclosed are:

- (X) Specification in TWENTY-THREE (23) pages.
- (X) SIX (6) sheets of drawings.
- (X) Return prepaid postcard.

Note:

## THIS APPLICATION IS FILED UNSIGNED AND UNPAID

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Assistant Commissioner for Patents PO BOX 1450 ALEXANDRIA, VA 22313-1450

## CERTIFICATE OF MAILING BY "EXPRESS MAIL"

Docket No.

JCLA12331

Inventor(s)

AKIRA ISHII;

JUN MITSUDO:

For

METHOD FOR MEASURING HEIGHT OF SHPERE OF

**HEMISPHERE** 

"Express Mail"

Mailing Label No.

: EV 300987746 US

**Date of Deposit** 

: October 8, 2003

I hereby certify that the accompanying

Transmittal in Duplicate; Specification in <u>23</u> page(s); <u>6</u> Pages of Drawings; Return Prepaid Postcard

are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Michelle Chang